



PATENT  
Atty. Dkt. No. AMAT/5297/KMT/KW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
Rivoire, et al.

Serial No.: 09/844,991

Confirmation No.: 1361

Filed: April 27, 2001

For: Method for Planarizing  
Organosilicate Layers

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

§§§§§ Group Art Unit: 3723

§§§§§ Examiner: Robert Rose

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TECHNOLOGY CENTER R3700

CERTIFICATE OF MAILING  
37 CFR 1.8

I hereby certify that this correspondence is being deposited on  
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12/19/03  
Date

Kent R. Miller  
Signature

**RESPONSE TO OFFICE ACTION DATED OCTOBER 21, 2003**

In response to the Office Action dated October 21, 2003, having a shortened statutory period for response set to expire on January 21, 2004, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no fee is due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/5297/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

**Amendments to the Specification** are shown beginning on page 2 of this paper. **Amendments to the Claims** are shown in the listing of the claims beginning on page 3 of this paper. **Remarks/Arguments** begin on page 7 of this paper.